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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

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Application Number	10/595,523
Filing Date	April 25, 2006
First Named Inventor	Masahiro Nakayama
Art Unit	(To be assigned) 2823
Examiner Name	(To be assigned). Jae Lee
Attorney Docket Number	39.071

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Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
1		Country Code ³ "Number * "Kind Code ⁵ (if known)	MM-DD-YYYY		Or Relevant Figures Appear	T°
W	F1	JP-H08-316187-A	11-29-1996	Kurita Water Ind. Ltd.	_	~
11	F2	JP H10-233382-A	09-02-1998	Hewlett Packard		~
11	F3	JP-2001-244240-A	09-07-2001	Speedfam		1
711	F4	JP-2003-218085-A	07-31-2003	Wacker NSCE Corp.		1
an	F5	JP-2002-043270-A	02-08-2002	Matsushita Electric		1
10	F6	JP-2001-322899-A	11-20-2001	Matsushita Electric		~

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Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
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Sheet	3	of	3	Attorney Docket Number	39.071	

O1 O2 O3	NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. L. H. PENG, et al., "Deep Ultraviolet Enhanced Wet Chemical Etching of Gallium Nitride," Applied Physics Letters, 23 February 1998, pp. 939-941, vol. 72, no. 8, American Institute of Physics, New York. D.A.STOCKER, et al., "Crystallographic Wet Chemical Etching of GaN," Applied Physics Letters, 2 November 1998, pp. 2654-2656, vol. 73, no. 18, American Institute of Physics, New York. J. A. BARDWELL, et al., "Ulrtaviolet Photoenhanced Wet Etching of GaN in K2S2O8 Solution," Journal of Applied Physics, 1 April 2001, pp. 4142-4149, vol. 89, no. 7, American Institute of Physics, New York.	T²
O2	Physics Letters, 23 February 1998, pp. 939-941, vol. 72, no. 8, American Institute of Physics, New York. D.A.STOCKER, et al., "Crystallographic Wet Chemical Etching of GaN," Applied Physics Letters, 2 November 1998, pp. 2654-2656, vol. 73, no. 18, American Institute of Physics, New York. J. A. BARDWELL, et al., "Ulrtaviolet Photoenhanced Wet Etching of GaN in K2S2O8 Solution," Journal of Applied Physics, 1 April 2001, pp. 4142-4149, vol. 89, no. 7, American Institute of	
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